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PATENT & TRADEMARK OFFICE

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CERTIFICATE OF MAILING

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E. R. Witt
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/614,465
Applicant : Tehsin Lee et al.
Title : METHOD AND SYSTEM FOR POST-TREATING DRY-ETCHED METAL FILM
Filed : July 7, 2003
TC/A.U. : (not yet assigned)
Examiner : (not yet assigned)
Docket No. : 3304.2.66
Customer No. : 21552

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY

Dear Sir:

In view of the fact that no action has been taken on this case since it was initially filed on July 7, 2003, Applicant respectfully requests a report concerning the status of the above-identified application.

Respectfully submitted,

E. R. Witt
Evan R. Witt
Reg. No. 32,512
Attorney for Applicants

Date: January 5, 2005

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